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Bib Data Sheet

CONFIRMATION NO. 9458

SERIAL NUMBER 10/072,073	FILING DATE 02/08/2002 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. TI-31619	
APPLICANTS Toshihito Tsuga, Tsuchiura-shi Ibaraki, JAPAN; Minoru Fube, Hayami-gun, JAPAN; Kazutaka Nakayama, Hayami-gun, JAPAN; ** CONTINUING DATA <i>MC (NONE)</i> ** FOREIGN APPLICATIONS <i>MC (Verified)</i> JAPAN 2001-032017 02/08/2001 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/07/2002					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>[Signature]</i> <i>MC</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 1
ADDRESS 23494					
TITLE Method for removing particles on semiconductor wafers					
FILING FEE RECEIVED 870	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		